China

CE, Rohs

A63.7003

5~20 Days

5000 pcs/ Month

1 pc

CNOEC, OPTO-EDU

FOB \$1~1000, Depend on Order Quantity

Carton Packing, For Export Transportation

# **OPTO-EDU A63.7003 Tungsten Filament Scanning Electron Microscope SE** BSE 360000x 4nm@20KV

### **Basic Information**

- Place of Origin:
- Brand Name:
- Certification:
- Model Number:
- Minimum Order Quantity:
- Price:
- Packaging Details:
- Delivery Time:
- Payment Terms: T/T, West Union, Paypal
- Supply Ability:





0

#### **Product Specification**

| <ul> <li>Resolution:</li> </ul>    | 4nm@20KV |
|------------------------------------|----------|
| <ul> <li>Magnification:</li> </ul> | 360000x  |
| Electron Gun:                      | Tungsten |
| <ul> <li>Voltage:</li> </ul>       | 3-20KV   |
| <b>D</b>                           |          |

- Detector:
- Navigation CCD:
- BSE+SE
- CCD+Cabin Camera

Magnification 360000x, Resolution 4nm@20KV(SE) With Detector SE+BSE+CCD, Optional EDS Standard X/Y Motorized Working Stage, Optional 3 Axis Stage XYZ, XYT, 5 Axis Stage XYZRT Built-in Condenser No Need Manual Adjust Aperture (LaB6 Optional) High Vaccum System With Mechanical Rotary Pump To Get Vaccum In 30s One Key Auto Focus, Auto Brightness & Contrast Adjust, No Need Shock Absorbing Table



# A63.7003

# Tungsten Filament Scanning Electron Microscope, SE+BSE, 360000x, 4nm@20KV



# <section-header><image><image><image><image>

**A63.7003 Desktop Scanning Electron Microscopes (SEM)** incorporate numerous innovative technologies, offering not only excellent imaging performance but also portability, catering to a wide range of application needs. Both domestically and internationally, the ZEM series, with its high-end positioning and diverse models, has achieved advanced standards in imaging clarity, user-friendliness, and system integration.

**A63.7003** is renowned for its high level of integration and flexible configuration options. The user interface is simple, easy to learn, and operate, allowing even non-expert users to quickly become proficient. The accompanying software supports the entire workflow, from sample preparation, parameter adjustment, to image analysis, providing an integrated and efficient solution. **A63.7003** has demonstrated strong analytical capabilities across multiple fields such as new materials, new energy, biomedicine, and semiconductors, assisting researchers in exploring the mysteries of the microscopic world. Due to its excellent cost-performance ratio, the ZEM series has become a preferred choice for many universities, research institutions, and enterprises seeking a desktop scanning electron microscope.

The A63.7003 benchtop SEM utilizes a wider range of accelerating voltages, 1Kvsteps, and a maximum magnification of 360,000x with a resolution of up to 5nmThe tabletop deceleration mode allows real-time observation of low-conductivity products without the need for gold spraying. The extra-large sample compartment can be integrated with a wide range of in-situ expansion platforms to meet different experimental and inspection needs.





#### **Working Conditions:**

Environmental requirements: small size, the whole machine can be placed on an ordinary laboratory table, no need to be equipped with an additional shock absorbing table.

1. Power supply 220V, 50Hz, 1KW

2.Temperature: Operating ambient temperature: 15°C-30°C

3.Humidity: <80%RH



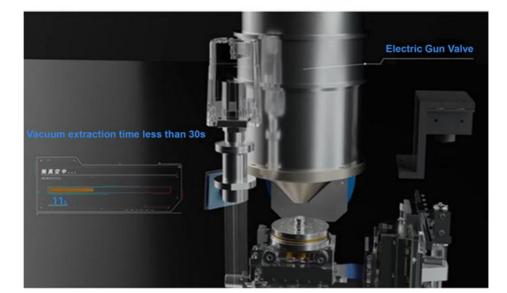
▲ Vacuum Separation Technology: Utilizes a unique vacuum design where the electron gun and sample chamber have separate vacuums, allowing for sample change in less than 1 minute.

▲ Extra-Large Sample Chamber: Provides a larger sample storage space for convenient user operation.

▲ Ultra-High Resolution: Achieves a maximum magnification of 360,000 times with a resolution of 4nm at 20kV.

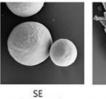
▲ Standard Equipped Deceleration Mode: Allows for the observation of weakly conductive samples without gold sputtering.

▲ In-Chamber Camera: The sample chamber is equipped with a high-definition camera for real-time monitoring of sample changes during in-situ experiments.



A63.7003 Specification









OPTO-EDU

EDS

#### **Main Specification:**

- 1. Acceleration voltage: 3-20kV, continuously adjustable.
- 2. Electron gun type: pre-aligned tungsten filament, life time 100 hours, easy to replace by user, highly integrated
- two-stage gun lens, no need to manually adjust the diaphragm of the objective lens.
- 3. Magnification ≥360000X
- 4. Resolution:≤4nm@20KV
- 5. Detector: secondary electron detector (SE), quadruple backscatter detector (BSE),
- 6. Stage: 2 Axis XY motorized stage, moving 60x55mm
- 7. Maximum sample size: 100\*78\*68.5mm while XY axes move freely
- 8. Sample change and high vacuum pumping time≤ 30s.

9. High vacuum system: built-in turbo molecular pump, external mechanical pump, the vacuum in sample

chamber  $\geq 1 \times 10$ -1Pa, fully automatic control;

10. Video mode ≥512x512 pixels, no need for small window scanning.

- 11. Quick scan mode: imaging time≤3s, 512x512 pixels.
- 12. Slow scan mode: imaging time≤40s, 2048x2048 pixels.
- 13. Image File: BMP, TIFF, JPEG, PNG.
- 14. One-key automatic adjustment of brightness and contrast, auto-focus, large image stitching
- 15. Navigation function: optical camera navigation and cabin camera.
- 16. Image measurement function: distance, angle, etc.
- 17. Including computer & software, mouse control.
- 18. Optional:

--Tungsten filament (20pcs/box)

--EDS

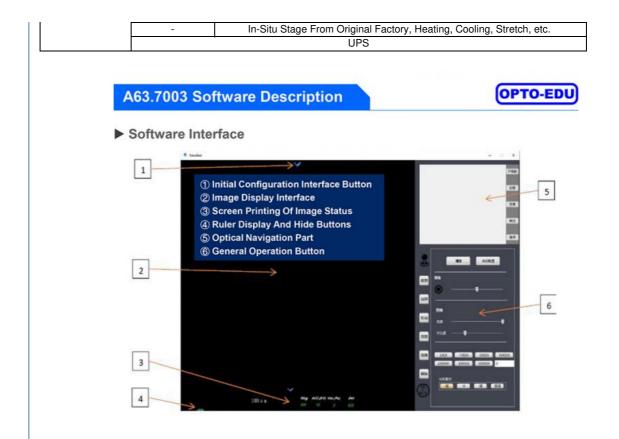
- --3 Axis Motorized Stage XYZ
- --3 Axis Motorized Stage XYT
- --5 Axis Motorized Stage XYZRT
- --Low vacuum (1-100Pa)
- --Deceleration Mode, 1-10KV, can observe non-conductor or poor conductivity samples without gold spraying, only for BSE mode

--In-Situ stage from original factory, heating, cooling, stretch, etc.

- --Shock-absorbing Platform (recommend for A63.7003)
- 19. Microscope size 650\*370\*642mm, mechanical pump size 340\*160\*140mm



| Model            | A63.7001                          | A63.7002                          | A63.7003   | A63.7004                                      | A63.7005   |  |
|------------------|-----------------------------------|-----------------------------------|--|---|--|--|
| Resolution       | 10nm@15KV                         | 6nm@18KV                          | 4nm@20KV   | 3nm@20KV                                      | 2.5nm@15KV                                       |  |
| Magnification    | 150000x                           | 200000x                           | 360000x  | 360000x                                       | 1000000x   |  |
| Electron Gun     | Tungsten                          | Tungsten                          | Tungsten   | LaB6  | Schotty FEG                                      |  |
| Voltage          | 5/10/15KV                         | 3-18KV                            | 3-20KV   | 3-20KV  | 1-15KV   |  |
| Detector         | BSE+SE                            | BSE+SE                            | BSE+SE   | BSE+SE  | BSE+SE   |  |
| Navigation CCD   | CCD                               | CCD                               | CCD+Cabin Camera                                       | CCD+Cabin Camera                              | CCD+Cabin Camera                                 |  |
| Vaccum Time      | 90s                               | 90s                               | 30s  | 90s   | 180s   |  |
| Vaccum System    | Mechanical Pump<br>Molecular Pump | Mechanical Pump<br>Molecular Pump | Mechanical Pump<br>Molecular Pump                      | Mechanical Pump<br>Molecular Pump<br>Ion Pump | Mechanical Pump<br>Molecular Pump<br>Ion Pump x2 |  |
| Vaccum           | High Vaccum<br>1x10-1Pa           | High Vaccum<br>1x10-1Pa           | High Vaccum<br>1x10-1Pa                                | High Vaccum<br>5x10-4Pa                       | High Vaccum<br>5x10-4Pa                          |  |
| Stage            | XY Stage,<br>40x30/40x40mm        | XY Stage,<br>40x30/40x40mm        | XY Stage,<br>60x55mm                                   | XY Stage,<br>60x55mm                          | XY Stage,<br>60x55mm                             |  |
| Stage Precision  | -                                 |                                   | Position I   | Precise 5um                                   |  |  |
| Working Distance | 5-35mm                            | 5-35mm                            | 5-73.4mm   | 5-73.4mm                                      | 5-73.4mm   |  |
| Max Specimen     | 80x42x40mm                        | 80x42x40mm                        | 100x78x68.5mm  | 100x78x68.5mm                                 | 100x78x68.5mm                                    |  |
|                  | Tung                              | gsten Filament 20 p               | ocs/box  | Lab6 Filament                                 | Field Emission Lamp                              |  |
|                  |                                   | EDS Oxfo                          | rd AZtecOne with Xp                                    | oreCompact 30                                 |  |  |
|                  | -                                 | Low Vaccum 1-100Pa                |  | Low Vaccum 1-30Pa                             |  |  |
|                  | -                                 | Z Axis Module                     | 3 Axis Sta   | tage, X 60mm, Y 50mm, Z 25mm                  |  |  |
|                  | -                                 | T Axis Module                     | 3 Axis Stage, X 60mm, Y 50mm, T ±20°                   |   | m, T ±20°  |  |
| Optional         | -                                 | -                                 | 5 Axis Stage, X 90mm, Y 50mm, Z 25mm, T ±20°, R 360°   |   |  |  |
|                  | -                                 | -                                 | Shock-absorbi  | ng Platform, For 3 Ax                         | is, 5 Axis Stage                                 |  |
|                  | -                                 | Deceleration M                    | Mode 1-10KV To Watch Non-conduct Samples, Only For BSE |   |  |  |
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## BSE Advanced Configuration

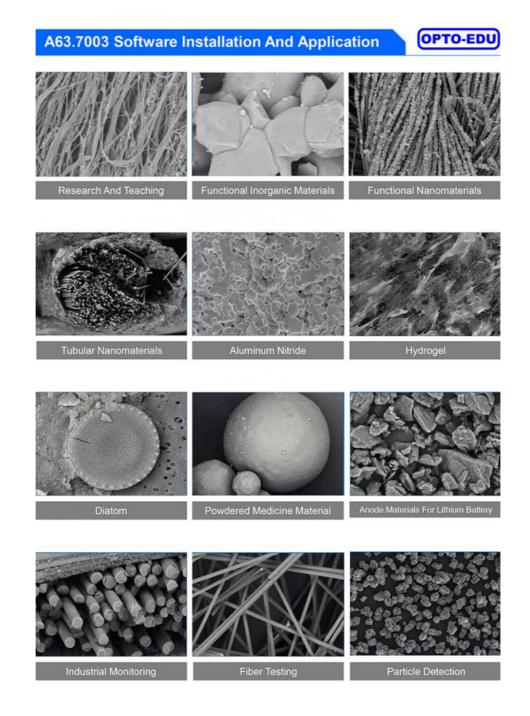


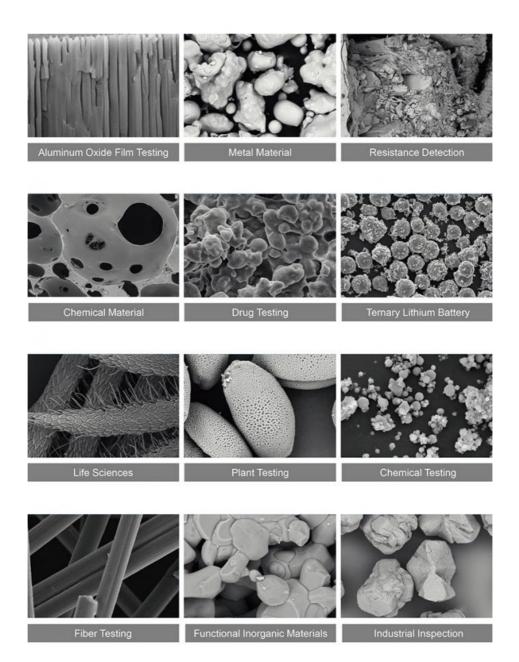
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► Turn Off The High Pressure, Vent The Vacuum.

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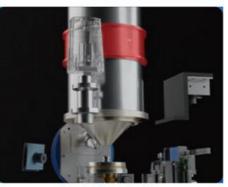


# A63.7003 Accessories

# OPTO-EDU



Optional 5-axis Center Sample Stage



Sample change time 30s



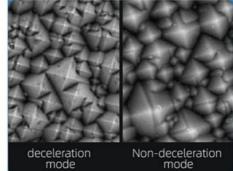
Addition of a camera inside the sample compartment for real-time observation of the sample compartment



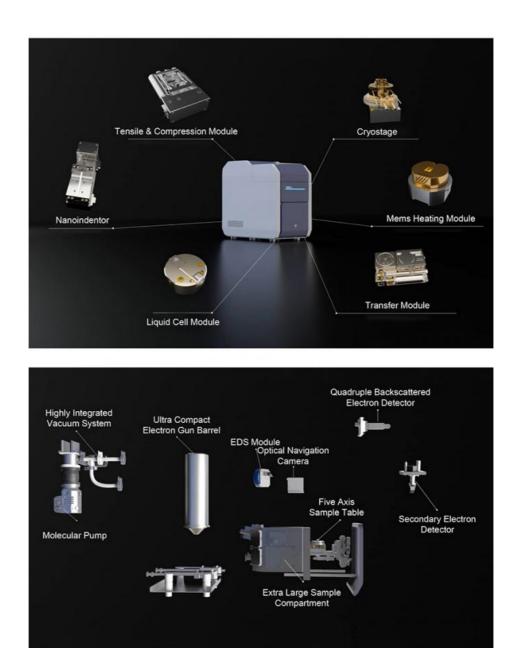
The gun head always maintains 5\*10'Pa vacuum, which greatly improves the service life of tungsten filament, and LaBó filament is optional

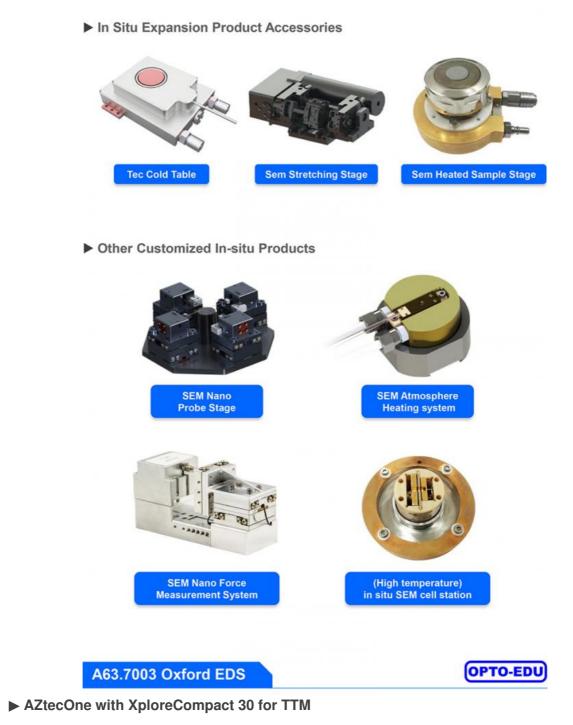


Extra large sample compartment,L185mm\*w176mm\*H125mm



10kv sample Table High Voltage Reduction Option

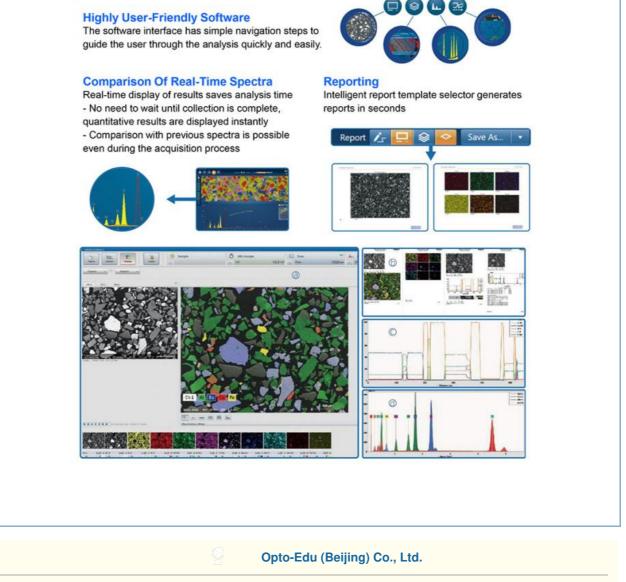




#### **System Conventional Eds Analysis**

The system provides qualitative and quantitative analysis of different materials, analyzing elements ranging from B(5) to cf (98).in addition to individual point scans of the sample surface, powerful line scans and elemental spectral scans are also available. combined with a customized detector, analysis and reporting can be done in seconds.

| Effective Crystal Area    | 30mm2            | Resolution (Of A Photo)  | Mn Ka <129eV @50,000cps |
|---------------------------|------------------|--------------------------|-------------------------|
| Elemental Detection Range | B (5) to cf (98) | Maximum Input Count Rate | >1,000,000 cps          |



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